



Docket No.: EHF 2001,0167 P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Norbert Benesch, Claus Schneider, Lothar Pfitzner
Applic. No. : 09/873,230
Filed : June 4, 2001
Title : Method and Device for Optically Monitoring Fabrication
Processes of Finely Structured Surfaces in a
Semiconductor Production

ASSOCIATE POWER OF ATTORNEY

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

Please recognize MARKUS NOLFF (Reg. No. 37,006) as my associate in the matter in the above-identified application, with full powers. Please continue addressing all communications to the following address:

Lerner and Greenberg, P.A.
P.O. Box 2480
Hollywood, Florida 33022-2480

Respectfully submitted,

For Applicants

WERNER H. STEMER
REG. NO. 34,956

Date: August 21, 2001

Lerner and Greenberg, P.A.
Post Office Box 2480
Hollywood, FL 33022-2480
Tel: (954) 925-1100
Fax: (954) 925-1101

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